

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/602,194
Applicant: Yoshi Ono
Filed: June 23, 2003
Group #: 2823
Examiner: Khiem D. Nguyen

Confirmation Number: 9996

Docket No: SLA.0669
Customer No: 27518
For: Low Temperature Nitridation of Silicon

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

PRELIMINARY AMENDMENT IN SUPPORT OF RCE UNDER 37 C.F.R. § 1.114
Introductory Comments

In response to the Office Action dated August 8, 2004, please amend the above-identified Application as follows:

Amendment to the Specification None

Amendment to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendment to the Drawings None

Remarks/Arguments begin on page 7 of this paper.

An Appendix is not included.

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